

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L2	1	"20020057406".pn	US-PGPUB; USPAT	OR	OFF	2005/02/22 10:06
L3	21	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack)and thick\$4 and 349/138	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/22 10:15
L4	21	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack)and thick\$4 and 349/138	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:45
L5	1	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack)and thick\$4 near10 ((pixel reflect\$4) and (bm shade shield))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:48
L6	0	((insult\$6 and (silicon adj (nitride or oxide))) near10 ((pixel reflect\$4) and (bm shade shield)))and (laminat\$5 or stack)and thick\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:49
L7	0	((insult\$6 and (silicon adj (nitride or oxide))) near10 ((pixel reflect\$4) and (bm shade shield)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:50
L8	202	((insult\$6 and (silicon adj (nitride or oxide))) and ((pixel reflect\$4) and (bm shade shield)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:50
L9	199	((insult\$6 and (silicon adj (nitride or oxide))) and ((pixel reflect\$4) and (bm shade shield))) and thick\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:50
L10	128	((insult\$6 and (silicon adj (nitride or oxide))) and ((pixel reflect\$4) and (bm shade shield))) and thick\$4 and (laminat\$4 double stack)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:56

L11	5	((insult\$6 and (silicon adj (nitride or oxide))) and ((pixel reflect\$4) and (bm shade shield))) and thick\$4 and (laminat\$4 double stack) and 349/138	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/02/22 10:56
S1	1633	(refractive adj index) near10 ((silicon adj oxide) or (silicon adj nitride))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/08/17 16:56
S2	53	(refractive adj index) near10 ((silicon adj oxide) or (silicon adj nitride)) and "349"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/08/17 16:57
S3	1	"6344888".pn	USPAT	OR	OFF	2005/02/22 10:06
S4	46263	insulat\$6 and moisture	USPAT; JPO	OR	OFF	2002/09/10 10:18
S5	10402	insulat\$6 with moisture	USPAT; JPO	OR	OFF	2002/09/10 10:18
S6	43	(insulat\$6 with moisture) and "349"/\$.ccls.	USPAT; JPO	OR	OFF	2003/05/15 16:47
S7	24	((insult\$6 with (silicon adj (nitride or oxide))) and laminat\$5	USPAT; JPO	OR	OFF	2002/10/15 14:31
S8	34	((insult\$6 with (silicon adj (nitride or oxide))) and (laminat\$5 or stack)	USPAT; JPO	OR	OFF	2003/05/15 16:47
S9	3883	((insult\$6 or dielectric) same (silicon adj (nitride or oxide))) and (laminat\$5 or stack)	USPAT; JPO	OR	OFF	2002/10/15 14:34
S10	3050	((insult\$6 or dielectric) with (silicon adj (nitride or oxide))) and (laminat\$5 or stack)	USPAT; JPO	OR	OFF	2002/10/15 14:34
S11	36	((insult\$6 or dielectric) near (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and periphery and ((semiconductor or silicon) adj substrate)	USPAT; JPO	OR	OFF	2002/10/15 14:40
S12	51	((insult\$6 or dielectric) near (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and periphery	USPAT; JPO	OR	OFF	2002/10/15 14:39
S13	375	((insult\$6 or dielectric) near (silicon adj (nitride or oxide))) and (laminat\$5 or stack)	USPAT; JPO	OR	OFF	2002/10/15 15:11
S14	14	((insult\$6 or dielectric) near (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and (liquid adj crystal)	USPAT; JPO	OR	OFF	2002/10/15 15:12

S15	41	("3862360" "3910681" "4024626" "4040727" "4073571" "4103297" "4185894" "4191452" "4239346" "4382658" "4431271" "4470060" "4602850" "4822144" "4839707" "4856019" "5007710" "5056895" "5159476" "5218472" "5254202" "5365355" "5395662" "5461501" "5467216" "5473448" "5497025" "5523862" "5570213" "5648860" "5680231" "5706067" "5760853" "5760981" "5764324" "5798805" "5828493" "5834103" "5838715" "5889570" "5978056").PN.	USPAT	OR	OFF	2002/10/15 15:13
S16	1	"6124912" pn.	USPAT	OR	OFF	2002/11/05 09:54
S17	63	(insulat\$6 with moisture) and "349"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2003/05/15 16:47
S18	68	(insulat\$6 with (silicon adj (nitride or oxide))) and (laminat\$5 or stack)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/21 15:46
S19	4	(insulat\$6 with (silicon adj (nitride or oxide))) and (laminat\$5 or stack)and (passivation near10 (reflect\$4 metal pixel))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/05/20 13:31
S20	46	(insulat\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack)and (passivation near10 (reflect\$4 metal pixel))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/22 10:15
S21	1650	349/113	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/04 14:10
S22	1329	349/138	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/04 14:11

S23	2268	349/42	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/04 14:11
S24	1523	349/43	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/04 14:11
S25	1409	349/153	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/06/04 14:11
S26	2	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and (passivation near10 (reflect\$4 metal pixel)) and 349/113	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/04 14:11
S27	0	(insult\$6 with (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and 349/113	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/04 14:12
S28	2	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and (passivation near10 (reflect\$4 metal pixel)) and 349/138	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/04 14:12
S29	3	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and (passivation near10 (reflect\$4 metal pixel)) and 349/42	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/04 14:12
S30	8	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and (passivation near10 (reflect\$4 metal pixel)) and 349/43	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/04 14:13
S31	0	(insult\$6 and (silicon adj (nitride or oxide))) and (laminat\$5 or stack) and (passivation near10 (reflect\$4 metal pixel)) and 349/153	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2004/06/04 14:13
S36	100	(insult\$6 near10 (silicon adj (nitride or oxide))) and (laminat\$5 or stack)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/02/21 15:47